



Attorney's Docket No.: 14225-049001 / F1040149US00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kiyoshi Mita
Serial No. : 10/813,782
Filed : March 31, 2004
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

Art Unit : 2815
Examiner : Chris C. Chu

MAIL STOP RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Prior to examination, please amend the application as indicated on the following pages.

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

October 18, 2005

Date of Deposit

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